



IFW

PATENT
Customer No. 22,852
Attorney Docket No. 02887.0259

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
)	
Junji SUGAMOTO et al.)	Group Art Unit: 2891
)	
Application No. 10/706,090)	Examiner: Smith, Bradley
)	
Filed: November 13, 2003)	
)	
For: SEMICONDUCTOR WAFER)	Confirmation No. 7292
TREATMENT METHOD,)	
SEMICONDUCTOR WAFER)	
INSPECTION METHOD,)	
SEMICONDUCTOR DEVICE)	
DEVELOPMENT METHOD AND)	
SEMICONDUCTOR WAFER)	
TREATMENT APPARATUS)	

Mailstop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

AMENDMENT

In reply to the Office Action mailed June 14, 2007, the period for response to which extends through September 14, 2007, please amend the above-referenced application as follows:

Amendments to the Claims are reflected in the listing of claims in this paper.

Remarks/Arguments follow the amendment section of this paper.